Ultra-Compact Si-GST Hybrid Waveguides for Nonvolatile Light Wave Manipulation

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Abstract: Phase change materials (PCMs) combined with silicon photonics are emerging as a promising platform to realize miniature photonic devices. We study the basic optical properties of a sub-wavelength-dimension silicon ridge waveguide with a 20-nm-thick Ge$_2$Sb$_2$Te$_5$ (GST) top-clad layer. Numerical simulations show that the effective index of the Si-GST hybrid waveguide varies significantly when the GST changes from the amorphous to the crystalline states. This change can be utilized to make micron-size photonic devices. To experimentally verify the effectiveness of the Si-GST hybrid waveguide on light wave manipulation, we fabricated a series of unbalanced Mach-Zehnder interferometers with one arm connected with a section of Si-GST hybrid waveguide in different lengths. The transmission spectra are measured and the complex effective indices are extracted for GST at crystalline, amorphous and intermediate phases. The experimental results overall agree well with the simulation ones. The nonvolatile property of GST makes it attractive to reduce the static power consumption. This research represents a significant step towards the realization of ultra-compact Si-GST hybrid devices that will play a key role in high-density photonic integrated circuits, opening the door to many potential applications, including optical switch, memory and logic operation. Corresponding authors: Linjie Zhou (e-mail: ljzhou@sjtu.edu.cn)

Index Terms: Integrated Photonic Devices, Optical Switching Devices, Phase Change Material.

1. Introduction

Over the past decade, silicon has become an attractive device integration platform with the potential of large-scale integrations of both passive and active photonic components, together with the electronic drive circuits [1-3]. In order to build compact devices, resonant structures, such as ring resonators [4], disk resonators [5], Bragg gratings [6], and photonic crystals [7] are intensively investigated. However, due to their resonant feature, the optical bandwidth is sacrificed, limiting their employment in multiple applications. In addition, the resonant devices are very sensitive to temperature change owing to the relatively large thermo-optic coefficient of silicon, leading to practically unacceptable stability issues.

Phase change materials (PCMs) possess at least two reversible phases and have been considered as one of the most promising candidates to overcome some fundamental limitations in today’s silicon photonic devices [8, 9]. The combination of PCMs with planar waveguides leads to ultrafast and ultra-compact optical devices [10]. In fact, the research of PCMs for optical applications began very early. The phase change was usually realized by laser irradiation. The first commercially successful application of PCMs was in rewritable optical data storage. At the same time, the scaling properties of the PCMs were studied [11-13]. It was found that the size effect starts to play an important role in the threshold field [14-16], the crystallization temperature [17-19], the crystallization speed [20, 21], and the work function [15]. The PCM transformation occurs in a time scale of nanosecond or even sub-nanosecond. The two stable and reversible states with distinguishable electrical, optical, and mechanical properties [22] make the PCM ideally suited for many potential optical applications, including display [23], optical signal processing [24], and optical switching [25-28]. In recent years, the scope for PCM has been extended to include oxides [8], such as vanadium dioxide. In this and other materials, the change in optical properties is enabled by temperature variation. However, the temperature-based phase change makes the devices volatile and need constant power to maintain one of its states [29].

The Ge$_2$Sb$_2$Te$_5$ (GST) is a well-known PCM material with its phase change occurred between crystalline (c-GST) and amorphous (a-GST) states. The phase change can be thermally [30], optically [26, 28, 31, 32] or electrically [33, 34] induced potentially with an ultra-high speed. Re-amorphization is achieved by heating the crystalline phase above the melting point followed by rapid cooling. Crystallization is achieved by heating above the glass transition temperature and then slowly cooling down [35]. The GST possesses the “self-holding” feature [27], with no static power consumption required to maintain the states.

This paper presents theoretical and experimental study of ultra-compact Si-GST hybrid waveguides. It is organized as follows. First, the H-field based full vectoral finite-element method is used to find the field profile and the effective index of the hybrid waveguide mode. The least squares boundary residual (LSBR) method is used to find the transmission coefficients between the two discontinuous waveguide sections. Next, the device fabrication process flow and measurement are presented. Then, we characterize the Si-GST hybrid waveguide at the telecommunication wavelengths. The last part
gives the conclusions.

2. Theoretical Analysis

We obtain the refractive indices of a-GST and c-GST using the VASE ellipsometer. Figure 1 shows the extracted complex refractive index $(n+ik)$ in dependence of wavelength. The increase of refractive index when GST transforms from the amorphous to the crystalline phase is due to a significant change in bonding [36]. Figure 2(a) shows the structure of a hybrid Si-GST waveguide. The silicon waveguide is a standard 500 nm (width) × 220 nm (height) single-mode waveguide with a slab layer thickness of 90 nm. A 20-nm-thick GST patch with a length of $L_{GST}$ is placed on top of the silicon waveguide to form the hybrid waveguide. Figures 2(b) and 2(c) show the transverse and longitudinal cross sections of the hybrid waveguide.

Fig. 1. Refractive index of GST as a function of wavelength. The GST is 20 nm thick on silicon substrate.

Fig. 2. (a) Schematic overview of the Si-GST hybrid waveguide. (b) Cross-sectional view along AA'. (c) Cross-sectional view along BB'.

We first study the property of the hybrid waveguide through numerical simulations. The operation wavelength is chosen at $\lambda = 1.55$ $\mu$m. The refractive indices of the materials at 1.55 $\mu$m are taken as $n_{Si} = 3.481$, $n_{SiO2} = 1.445$, $n_{a-GST} = 3.9027+0.0055i$ and $n_{c-GST} = 6.0769+0.9040i$. The complex refractive index of GST is obtained from Fig. 1. We first use the H-field based full vectoral finite-element method (VFEM) to obtain the modal solutions of the waveguide. The VFEM has been established as one of the most accurate and numerically efficient approaches to obtain the modal field profiles and propagation constants of the fundamental and higher-order quasi-TE and quasi-TM modes. The full vectorial formulation is based on the minimization of the following energy function in terms of the nodal values of the full H-field vector [37]:

$$
\omega^2 = \left[ (\nabla \times H)^2 \cdot \varepsilon^{-1} \cdot (\nabla \times H) + \rho (\nabla \cdot H)^2 \cdot (\nabla \cdot H) \right] d\Omega
$$

where $H$ is the full vectorial magnetic field, $\omega$ denotes the complex conjugate and transpose, $\varepsilon$ and $\mu$ are the permittivity and permeability, respectively, $\omega^2$ is the eigenvalue, where $\omega$ is the optical angular frequency of the wave, and $\rho$ is a weighting factor for the penalty term.

When GST is in the amorphous phase, a low-loss quasi-TE polarized mode is supported and shown in Fig. 3(a), which is similar to the quasi-TE mode of a single-mode Si ridge waveguide. This quasi-TE mode has a calculated effective index of $n_{eff} = 2.6328$ and a propagation loss of 0.013 $\text{dB}/\mu$m. When GST is in the crystalline state, the waveguide supports a lossy mode as shown in Fig. 3(b). This lossy mode has a calculated effective index of $n_{eff} = 2.8324$ and a propagation loss of 4.038 $\text{dB}/\mu$m. Therefore, upon phase change of the GST material, the Si-GST hybrid waveguide can provide 4.025 $\text{dB}/\mu$m extinction ratio (ER), which is defined as the ratio between the maximum and the minimum output power transmissions.
The power confinement factor, $\Gamma_{\text{mat}}$, measuring how well the optical power is confined in a certain material, is defined as [38]:

$$\Gamma_{\text{mat}} = \frac{\int_{\Omega_{\text{mat}}} E^* \times H \, dx \, dy}{\int_{\Omega} E^* \times H \, dx \, dy}$$

where the numerator integrates over the material region, $\Omega_{\text{mat}}$, while the denominator integrates over the entire cross-section of the waveguide, $\Omega$. Following this, $\Omega_{\text{Si}}$ of the hybrid waveguide is 74.4% and $\Omega_{\text{GST}}$ is 3.9% when GST is in the amorphous state; $\Omega_{\text{Si}}$ reduces to 69.7% and $\Omega_{\text{GST}}$ increases to 6% when GST is in the crystalline state. Besides, as the confinement in GST increases, the crystalline state has a larger propagation constant and a higher optical absorption loss.

The discontinuity between the regular silicon waveguide and the Si-GST hybrid waveguide introduces a waveguide junction, causing light scattering loss. The LSBR method has been applied on a wide range of discontinuity problems involving an abrupt change at the transverse plane. It can be used to achieve an accurate waveguide junction analysis and to obtain the power transfer. The LSBR method looks for a stationary solution to satisfy the continuity conditions for the tangential fields in a least squares sense by minimizing the error energy function $J$, which is defined as [39]:

$$J = \int \left[ |E^I - E^II|^2 + \alpha \cdot Z_0 |H^I - H^II|^2 \right] \, d\Omega$$

Where $E^I$, $H^I$, $E^II$, and $H^II$ are the transverse electric and magnetic fields in the regular silicon waveguide and the Si-GST hybrid waveguide, respectively, $Z_0$ is the free-space impedance, and $\alpha$ is the dimensionless weighting factor to balance the electric and magnetic components of the error function $J$. The integration is carried out over the entire junction interface $\Omega$.

When GST is in the amorphous state, the total transmission loss through the two junctions is 0.09 dB for a 5-μm-long Si-GST hybrid waveguide. On the other hand, when GST is in the crystalline state, the total transmission loss increases to 20.5 dB.

To confirm the LSBR calculated results, we also perform the 3D finite-difference time-domain (FDTD) simulations. The fundamental quasi-TE mode of the silicon waveguide is launched into the input waveguide, and the transmitted power at the output end is monitored. Figures 3(c) and 3(d) show the electric field distributions along the waveguide longitudinal direction for the two states of GST, respectively. For the “on” state, where GST is in amorphous, the light can pass through the hybrid waveguide section with slight field attenuation. The transmission loss is 0.17 dB. However, for the “off” state, where GST is in crystalline, the field is rapidly attenuated when it goes into the hybrid waveguide section. The light is absorbed in the GST layer. The transmission loss is 24.1 dB. The FDTD results are overall consistent with the LSBR calculations.

3. Device Fabrication

To extract the effective index change of the Si-GST hybrid waveguide upon phase change, we designed an unbalanced Mach-Zehnder interferometer (MZI) structure as shown in Fig. 4(a). The MZI is composed of two 2 × 2 couplers connected by two waveguide arms with a length difference of $\Delta L = 400$ μm. The Si-GST hybrid waveguide with a length $L_{\text{GST}}$ is placed in the longer arm. We measured devices with various $L_{\text{GST}}$ values from 0.3 μm to 7 μm. Figure 4(b) shows the optical microscope image of one typical device.
The devices were fabricated on a silicon-on-insulator wafer with a 220-nm thick top silicon layer and a 2-µm-thick buried oxide layer. The silicon waveguides were defined by 248 nm deep ultraviolet (DUV) photolithography and then etched by inductively coupled plasma (ICP) dry etch. Subsequently, poly-methyl-meth-acrylate (PMMA) resist was spin-coated and electron-beam lithography was used to define the GST window. A 20-nm-thick GST film was deposited using radio frequency (RF) sputtering from a stoichiometric Ge2Sb2Te5 alloy target (20 W, 15 s.c.c.m. Argon gas, 0.0889 nm/min deposition rate). With RF sputtering, the composition of the deposited material was maintained. The GST was then patterned using lift-off process in a warm acetone bath.

So far, most research has focused on the switching properties of GST between a-GST and c-GST. However, during the phase transition, the GST film could also be at intermediate phases (i-GST) which incorporate combined portions of amorphous and crystalline phases. By controlling the degree of partial crystallization, the intermediate phase of GST can be produced, and thus a multi-level switchable optical property can be obtained for the GST film. The intermediate phase of the GST is dominated by both the annealing time and the annealing temperature.

The transmission spectrum of the devices was measured using a tunable laser scanning from 1520 nm to 1580 nm with a step size of 5 pm. A polarization controller was used to adjust the polarization to quasi-TE mode. Two single-mode fibers mounted at an angle of 10° were employed to couple light into and out of the device through on-chip grating couplers. The grating couplers were designed to be linearly chirped with an etched depth of 70 nm. The measured transmission spectra were all normalized to a reference straight waveguide to eliminate the influence of the grating couplers.

The waveguide effective index is determined not only by the refractive index of the waveguide material but also by the waveguide geometry and its surrounding. The evanescent interaction of the waveguide mode with the GST film results in a change in both the real and imaginary parts of the effective index. For each MZI, four transmission spectra from two input ports to two output ports were measured. The real part of the effective index change affects the phase of the arm, and thus the spectral shift. On the other hand, the imaginary part affects the loss of the arm, and thus the extinction ratio of the interference fringe in the spectrum. Therefore, by measuring the spectral shift and extinction ratio variation, we can extract the complex effective index change of the hybrid waveguide.

As a reference, the transmission spectra of MZIs without GST cladding were first tested. Next, the MZIs sputtering-coated with different lengths of GST patches were measured as state-1. Because the sputtering temperature is lower than the GST phase transition temperature, the as-deposited GST alloy is initially in the amorphous phase. In the state-2 and state-3, the devices were annealed for 4 min at 100 °C and 200 °C on a hot plate to reach i-GST, respectively. In the state-4, a 4-min annealing process at 245 °C on a hot plate was performed to obtain the c-GST. All samples were annealed in air.

4. Experimental Result and Discussion

Figure 5 shows the measured MZI spectra from input port-a to output port-c (see Fig. 4(b)) at different states. The Si-GST hybrid waveguide is 5 µm long. The interference fringe exhibits a high extinction ratio (>25 dB) when the GST is in the amorphous state, while it has a much lower extinction ratio (~5 dB) when GST changes to the crystalline state. This indicates that the c-GST has a much higher loss, leading to unbalanced optical power in the two arms. It is also observed that the fringe shifts after phase change, implying the real part of the effect index also varies.

To extract the effective index change, we use the transfer matrix method to model the MZI. The output fields $E_2$ and $E_3$ are related to the input fields $E_a$ and $E_b$ as:

$$
\begin{bmatrix}
E_2 \\
E_3
\end{bmatrix} =
\begin{bmatrix}
\tau_2 & j\kappa_2 \\
jk_2 & \tau_2
\end{bmatrix}
\begin{bmatrix}
A \exp(j\phi) & 0 \\
0 & 1
\end{bmatrix}
\begin{bmatrix}
\tau_1 & j\kappa_1 \\
jk_1 & \tau_1
\end{bmatrix}
\begin{bmatrix}
E_a \\
E_b
\end{bmatrix}
$$

\[ (4) \]

where $\tau_i$ and $\kappa_i$ (i = 1, 2) are the field transmission and coupling coefficients of the couplers, respectively, $A$ is the loss factor of the longer arm relative to the shorter one, and $\phi$ represents the phase difference between the MZI arms. We assume that the silicon waveguide loss is negligible compared to the Si-GST waveguide. The loss factor $A$ is determined by the Si-GST waveguide and given by...
\[ A = \exp(-\frac{2\pi \cdot k_{\text{eff}} \cdot L_{\text{GST}}}{\lambda}) \]  

where \( \lambda \) is the operation wavelength and \( k_{\text{eff}} \) is the imaginary part of the hybrid waveguide effective index. The phase difference \( \phi \) is expressed as

\[ \phi = \frac{2\pi}{\lambda} \left[ n_{\text{eff}} \cdot L_{\text{GST}} + n_{\text{eff,Si}} \left( \Delta L - L_{\text{GST}} \right) \right] \]

where \( n_{\text{eff}} \) and \( n_{\text{eff,Si}} \) are the effective indices of the hybrid silicon waveguide and regular silicon waveguide, respectively. The phase shift \( \Delta \phi \) in the longer arm induces a spectral shift \( \Delta \lambda = \Delta \phi \cdot \text{FSR}/2\pi \) with FSR being the free spectral range of the interference pattern. The real part of the effective index change \( \Delta n_{\text{eff},i} \) at state-\( i \) with respect to the reference (without GST) is given by

\[ \Delta n_{\text{eff},i} = \frac{\lambda}{\text{FSR}} \frac{\Delta \lambda_i}{L_{\text{GST}}} \quad (i = 1, 2, 3, 4) \]

where \( \Delta \lambda_i \) is the spectral shift for state-\( i \).

Figure 5. Measured MZI transmission spectra when GST is at different states.

Figure 6(a) shows \( \Delta \lambda_i \) as a function of \( L_{\text{GST}} \) obtained from the transmission spectrum measurement. As expected, \( \Delta \lambda_i \) linearly increases with \( L_{\text{GST}} \). The spectral shift \( \Delta \lambda_2 \) for state-2 is almost overlapped with \( \Delta \lambda_1 \) for state-1 (without annealing), suggesting that the 100°C annealing has a negligible effect on GST. From state-2 to state-4, the spectral shift increases with the annealing temperature. The maximum shift is achieved when the a-GST is fully converted to the c-GST at an annealing temperature of 245°C. It implies that the GST undergoes crystallization via an accumulated process. The i-GST was obtained at a moderate annealing temperature of 200°C in our experiment. In the intermediate states, small grains distribute uniformly over the observing area. The hexagonal-close-pack (HCP) phase co-exists with the face-center-cube (FCC) phase [41, 42]. By controlling the degree of partial crystallization, multi-level i-GST can be reached correspondingly. With linear fitting to the experimental spectral shift data and using (7), we can extract \( \Delta n_{\text{eff},i} \).

Figure 6. (a) Spectral shift and (b) excess loss as a function of Si-GST hybrid waveguide length. The dots represent the experimental data and the straight lines are the linear fitting lines.

The loss factor \( A_i \) of the hybrid waveguide can be extracted by measuring the extinction ratios \( R_{\text{ac},i} \), \( R_{\text{ad},i} \), \( R_{\text{bc},i} \), and \( R_{\text{bd},i} \) of the four optical spectra, according to the following formula [43]:

\[ R_{\text{ext}} = \frac{R_{\text{bc},i} \cdot R_{\text{bd},i}}{R_{\text{ac},i} \cdot R_{\text{ad},i}} \]
\[ A = \frac{\sqrt{R_{ad,j} + (-1)^{m} R_{bd,j} + (-1)^{n} R_{cd,j}}}{\sqrt{R_{bd,j} - (-1)^{n} R_{cd,j}} - (-1)^{m}} \]

\[ \Delta n_{\text{eff},i} = \frac{\Delta L_{\text{GST}}}{\Delta \text{GST}} \]

where \( m, n, l, p \) are integers, taking 0 or 1. Following that, \( k_{\text{eff},i} \) can be obtained for the four states using Eq. (5). Figure 6(b) shows the excess loss, \(-20 \log(w(A)_{i})\), of the hybrid waveguide as a function of GST when GST changes from state-1 to state-4.

Table 1 summarizes the extracted parameters for various GST states. The deposition of a-GST on the silicon waveguide causes its effective index to increase by 0.0924. After phase change to c-GST, the effective index increases by 0.259. The refractive index tuning range is thus 0.167, which is slightly smaller than the simulated value of 0.2. This presents an ultra-large refractive index tuning range compared to the thermo-optic or electro-optic effects in silicon. The propagation loss of the Si-GST hybrid waveguide is 0.05 dB/\( \mu \text{m} \) and 3.72 dB/\( \mu \text{m} \) for a-GST and c-GST, respectively. The simulation gives 0.013 dB/\( \mu \text{m} \) and 4.038 dB/\( \mu \text{m} \) propagation loss for the two states, slightly different from the experimental results.

<table>
<thead>
<tr>
<th>State #</th>
<th>Annealing Condition</th>
<th>( \Delta L_{\text{GST}} ) (nm/( \mu \text{m} ))</th>
<th>( \Delta n_{\text{eff},i} )</th>
<th>( k_{\text{eff},i} )</th>
<th>Loss (dB/( \mu \text{m} ))</th>
</tr>
</thead>
<tbody>
<tr>
<td>1</td>
<td>no</td>
<td>0.0964</td>
<td>0.0924</td>
<td>0.004</td>
<td>0.05</td>
</tr>
<tr>
<td>2</td>
<td>100°C, 4min</td>
<td>0.0932</td>
<td>0.0846</td>
<td>0.0041</td>
<td>0.05</td>
</tr>
<tr>
<td>3</td>
<td>200°C, 4min</td>
<td>0.237</td>
<td>0.244</td>
<td>0.083</td>
<td>2.77</td>
</tr>
<tr>
<td>4</td>
<td>245°C, 4min</td>
<td>0.263</td>
<td>0.259</td>
<td>0.113</td>
<td>3.72</td>
</tr>
</tbody>
</table>

The discrepancy can be caused by several factors. The GST film thickness is taken to be 20 nm in the simulation. However, in the real device, the thickness may deviate slightly. Figure 7 illustrates the impact of the GST film thickness variation on the hybrid waveguide effective index and propagation loss. It can be seen that when the thickness reduces by approximately 2 nm to 18 nm, both the effective index change and propagation loss at c-GST state have good agreement with the simulation. The measured higher loss at a-GST state is probably caused by the scattering loss due to the surface roughness of the GST layer. This scattering loss is likely overwhelmed by the material absorption loss in the c-GST state.

![Fig. 7. VFEM simulation results showing the dependence of (a) the real part of the effective index and (b) propagation loss of the Si-GST hybrid waveguide on the GST film thickness.](image)

It has been shown that partial crystallization exists due to the accumulation process of the GST crystallization. As the degree of partial crystallization increases, the spectrum experiences gradual red shift with continuously reduced extinction ratio. Here, the crystallization and re-amorphization processes of the GST are enabled by thermal annealing. In fact, other stimulation methods can also be used, such as illumination by a laser with high peak power or using an electrical pulse. The typical switching time for electrical stimulation is in the order of nanoseconds. The silicon waveguide geometry used in our experiment also supports the quasi-TM mode with a high field amplitude at the top surface of the waveguide, which can potentially increases the interaction with the GST film [44]. The GST material itself has a higher loss (especially for c-GST) than silicon. However, in our hybrid waveguide design, a thin layer of GST only covers a very short length of silicon waveguide. It is enough to tune the effective index of the hybrid waveguide. For a 1-\( \mu \text{m} \)-long hybrid waveguide, the phase change of GST can lead to a considerable amount of spectral shift, and the excess loss at the a-GST state is only 0.05 dB, which is almost negligible. It can be employed to make 1x2 optical switches, for instance. It should be noted GST possess much lower loss in the longer wavelength band from 1800 nm to 2100 nm [45]. The hybrid waveguide propagation loss can be reduced considerably in this wavelength band. The GST material that we used is just one type of candidate phase-change material. In fact, there exist a great variety of other phase-change materials, such as GeSe [27], Ge\(_2\)Sb\(_2\)Se\(_5\)Te\(_1\) [46], etc. They have lower loss at the 1550 nm wavelength, which are worth further exploration in the future work.
We have investigated a Si-GST hybrid waveguide that can be used for nonvolatile light wave manipulation. The hybrid waveguide experiences a large refractive effective index modulation upon phase change of the GST material. Using an unbalanced MZI structure with one arm connected with a Si-GST hybrid waveguide, we extracted the complex refractive index changes at various GST phase states. The real part effective index change from a-GST to c-GST is 0.167. The propagation loss of the Si-GST hybrid waveguide for a-GST and c-GST is 0.05 dB/μm and 3.72 dB/μm, respectively. The experimental results overall agree with the simulation prediction. The crystallization level can be well controlled by adjusting the annealing conditions, resulting in intermediate GST phases. The GST possesses the “self-holding” feature, making it very attractive for low power applications. The Si-GST hybrid waveguide can be used to construct micrometer-sized photonic devices, paving the way for realization of ultra-compact photonic integrated circuits.

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